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(BHGL No. 10808/125)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Teng-Wang Huang et al.

Serial No: 10/789,118

Examiner: NGUYEN, Ha T.

Filed: February 27, 2004

Group Art Unit: 2812

For: LINER MASK FOR SEMICONDUCTOR
APPLICATIONS

AMENDMENT AND ELECTION

Mail Stop Amendment
Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed on June 16, 2005, Applicants submit this Amendment and Election. Applicants respectfully requests consideration of the amendments, withdrawal the restriction requirement, and examination of the application in view of the following remarks.

Amendments to the Claims are reflected in the listing of claims which begin on page 2.

Remarks begin on page 5 of this paper.